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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10076237	FILING DATE 02/13/2002	CLASS 438	SUBCLASS 480	GAU 2812	EXAMINER E. J. F. [Signature]
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**APPLICANTS: Jang Tae-Ho;

NOPE MC
**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2001-08111 02/19/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no KG
ATTORNEY DOCKET NO 2522-13		
TITLE : Silicon-on-insulator (SOI) substrate and method for manufacturing the same U.S. DEPT. OF COMM /PAT. & TM-PTO-436L (Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.	Print Fig.
TERMINAL DISCLAIMER		Primary Examiner		
		PREPARED FOR ISSUE		
		Application Examiner		
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